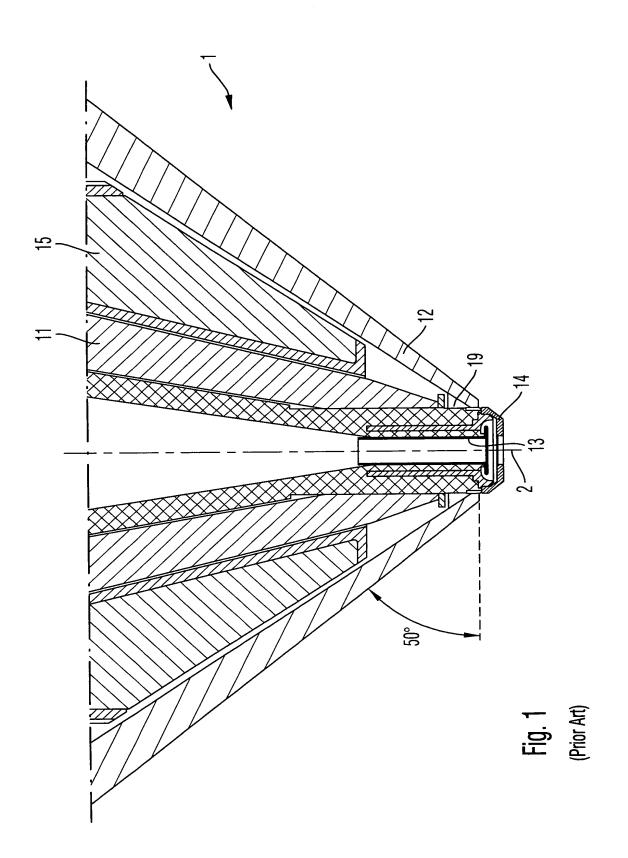
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

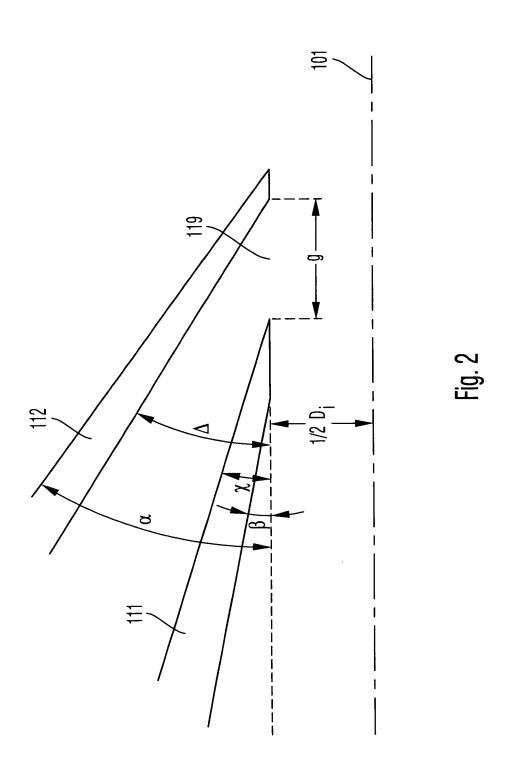
INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

SHEET 1 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM INVENTOR(S): DIRK PREIKSZAS ET AL.
APPLICATION SERIAL NO: 007413-058

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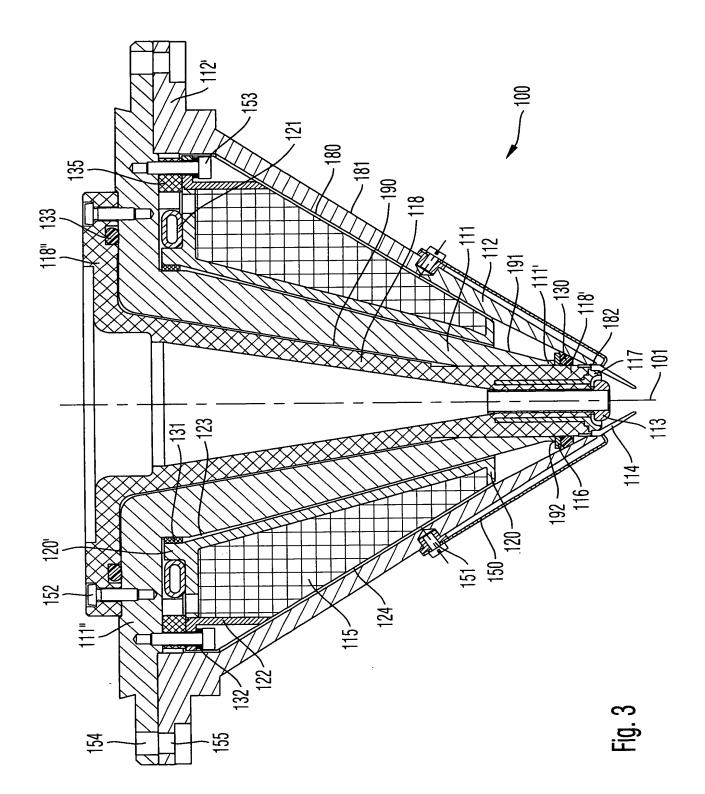
APPLN. FILING DATE: JULY 16, 2003

TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY

SYSTEM AND ELECTRON MICROSCOPY SYSTEM

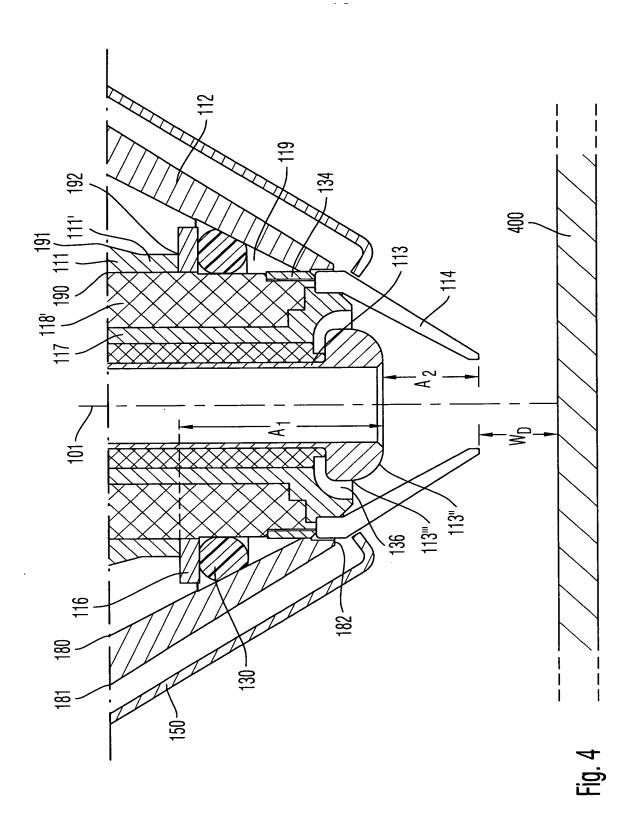
INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

SHEET 3 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM INVENTOR(S): DIRK PREIKSZAS ET AL.
APPLICATION SERIAL NO: 007413-058

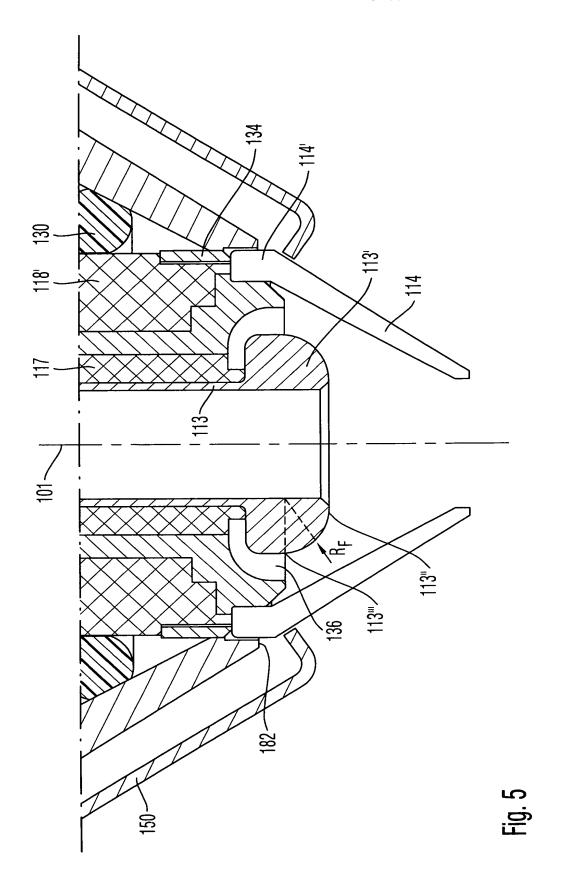
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APPLN. FILING DATE: JULY 16, 2003
TITLE: OBJECTIVE LENS FOR AN ELECTRON MICROSCOPY
SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

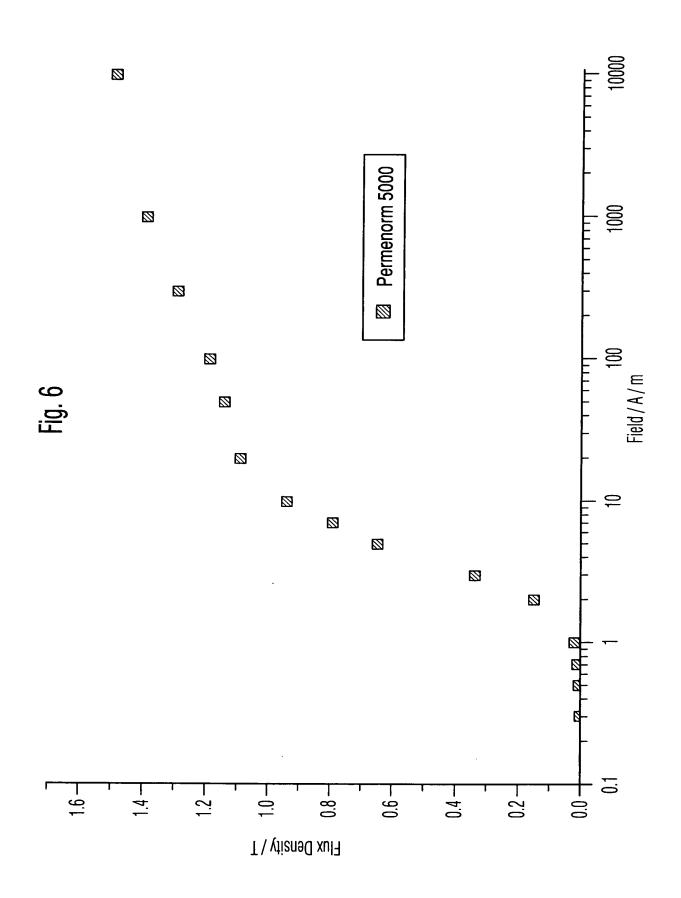
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SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL.

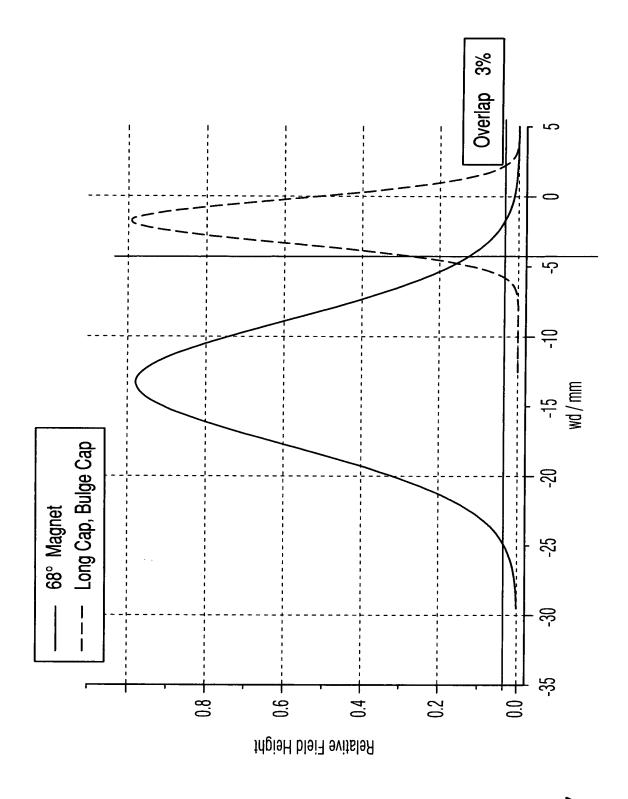
APPLICATION SERIAL NO: 007413-058 SHEET 6 of 8



SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

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SYSTEM AND ELECTRON MICROSCOPY SYSTEM

INVENTOR(S): DIRK PREIKSZAS ET AL. APPLICATION SERIAL NO: 007413-058

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